

A METHOD OF FABRICATING STRUCTURED PARTICLES COMPOSED
OF SILICON OR A SILICON-BASED MATERIAL AND THEIR USE IN
LITHIUM RECHARGEABLE BATTERIES.

5 The invention relates to a particle comprising silicon, a method of fabricating a particle, an electrode containing particles as its active material, an electrochemical cell, a lithium rechargeable cell anode, a cell, a device powered by a cell, a method of creating a composite electrode, a method of fabricating a lithium rechargeable cell and a method of fabricating silicon-comprising fibres.

10

The recent increase in the use of portable electronic devices such as mobile telephones and notebook computers and the emerging trend of using rechargeable batteries in hybrid electric vehicles has created a need for smaller, lighter, longer lasting rechargeable batteries to provide the power to the above mentioned and other battery powered devices. During the 1990s, lithium rechargeable batteries, specifically lithium-ion batteries, became popular and, in terms of units sold, now dominate the portable electronics marketplace and are set to be applied to new, cost sensitive applications. However, as more and more power hungry functions are added to the above mentioned devices (e.g. cameras on mobile phones), improved and lower cost batteries that store more energy per unit mass and per unit volume are required.

20

It is well known that silicon can be used as the active anode material of a rechargeable lithium-ion electrochemical battery cell (see, for example, Insertion Electrode Materials for Rechargeable Lithium Batteries, M. Winter, J. O. Besenhard, M. E. Spahr, and P. Novak in Adv. Mater. 1998, 10, No. 10). The basic composition of a conventional lithium-ion rechargeable battery cell is shown in Fig. 1 including a graphite-based anode electrode, the component

25

2

to be replaced by the silicon-based anode. The battery cell includes a single cell but may also include more than one cell.

5 The battery cell generally comprises a copper current collector for the anode 10 and an aluminium current collector for the cathode 12 which are externally connectable to a load or to a recharging source as appropriate. A graphite-based composite anode layer 14 overlays the current collector 10 and a lithium containing metal oxide-based composite cathode layer 16 overlays the current collector 12. A porous plastic spacer or separator 20 is provided between the
10 graphite-based composite anode layer 14 and the lithium containing metal oxide-based composite cathode layer 16 and a liquid electrolyte material is dispersed within the porous plastic spacer or separator 20, the composite anode layer 14 and the composite cathode layer 16. In some cases, the porous plastic spacer or separator 20 may be replaced by a polymer electrolyte material and in
15 such cases the polymer electrolyte material is present within both the composite anode layer 14 and the composite cathode layer 16.

When the battery cell is fully charged, lithium has been transported from the lithium containing metal oxide via the electrolyte into the graphite-based layer
20 where it reacts with the graphite to create the compound, LiC_6 . The graphite, being the electrochemically active material in the composite anode layer, has a maximum capacity of 372 mAh/g. It will be noted that the terms “anode” and “cathode” are used in the sense that the battery is placed across a load.

25 It is generally believed that silicon, when used as an active anode material in a lithium-ion rechargeable cell, provides a significantly higher capacity than the currently used graphite. Silicon, when converted to the compound $\text{Li}_{21}\text{Si}_5$ by reaction with lithium in an electrochemical cell, has a maximum capacity of 4,200 mAh/g, considerably higher than the maximum capacity for graphite.

3

Thus, if graphite can be replaced by silicon in a lithium rechargeable battery the desired increase in stored energy per unit mass and per unit volume can be achieved.

5 Existing approaches of using a silicon or silicon-based active anode material in a lithium-ion electrochemical cell have failed to show sustained capacity over the required number of charge/discharge cycles and are thus not commercially viable.

10 One approach disclosed in the art uses silicon in the form of a powder (say as particles or spherical elements with a 10 μ m diameter), in some instances made into a composite with or without an electronic additive and containing an appropriate binder such as polyvinylidene difluoride coated onto a copper current collector. However, this electrode system fails to show sustained
15 capacity when subjected to repeated charge/discharge cycles. It is believed that this capacity loss is due to partial mechanical isolation of the silicon powder mass arising from the volumetric expansion/contraction associated with lithium insertion/extraction to and from the host silicon. In turn this gives rise to electrical isolation of the silicon elements from both the copper current
20 collector and themselves. In addition, the volumetric expansion/contraction causes the spherical elements to be broken up causing a loss of electrical contact within the spherical element itself.

Another approach known in the art designed to deal with the problem of the
25 large volume changes during successive cycles is to make the size of the silicon elements that make up the silicon powder very small, that is to use spherical particles that have diameters in the 1-10 nm range. This strategy assumes that the nano-sized elements can undergo the large volumetric expansion/contraction associated with lithium insertion/extraction without

being broken up or destroyed. However, this approach is problematic in that it requires the handling of very fine, nano-sized powder that may pose a health and safety risk and it does not prevent the electrical isolation of the spherical elements from both the copper current collector and themselves as the silicon powder undergoes the volumetric expansion/contraction associated with lithium insertion/extraction. Importantly, the large surface area of the nano-sized elements can give rise to the creation of a lithium-containing surface film that introduces a large irreversible capacity into the lithium-ion battery cell. In addition, the large number of small silicon particles creates a large number of particle-to-particle contacts for a given mass of silicon and these each have a contact resistance and may thus cause the electrical resistance of the silicon mass to be too high. The above problems have thus prevented silicon particles from becoming a commercially viable replacement for graphite in lithium rechargeable batteries and specifically lithium-ion batteries.

In another approach described by Ohara *et al.* in Journal of Power Sources 136 (2004) 303-306 silicon is evaporated onto a nickel foil current collector as a thin film and this structure is then used to form the anode of a lithium-ion cell. However, although this approach gives good capacity retention, this is only the case for very thin films (say ~50 nm) and thus these electrode structures do not give usable amounts of capacity per unit area. Increasing the film thickness (say >250 nm) causes the good capacity retention to be eliminated. The good capacity retention of these thin films is considered by the present inventors to be due to the ability of the thin film to absorb the volumetric expansion/contraction associated with lithium insertion/extraction from the host silicon without the film being broken up or destroyed. Also, the thin film has a much lower surface area than the equivalent mass of nano-sized particles and thus the amount of irreversible capacity due to the formation of a lithium-containing surface film is reduced. The above problems have thus prevented a

thin film of silicon on a metal foil current collector from becoming a commercially viable replacement for graphite in lithium rechargeable batteries and specifically lithium-ion batteries.

- 5 In another approach described in US2004/0126659, silicon is evaporated onto nickel fibres which are then used to form the anode of a lithium battery.

However this is found to provide an uneven distribution of silicon on the nickel fibres hence significantly affecting operation. In addition, these structures have
10 a high ratio of nickel current collector mass to active silicon mass and thus do not give usable amounts of capacity per unit area or per unit mass.

A review of nano- and bulk-silicon-based insertion anodes for lithium-ion secondary cells has been provided by Kasavajjula et al (J. Power Sources
15 (2006), doi:10.1016/j.powsour.2006.09.84), herewith incorporated by reference herein.

Another approach described in UK Patent Application GB2395059A uses an silicon electrode comprising a regular or irregular array of silicon pillars
20 fabricated on a silicon substrate. These structured silicon electrodes show good capacity retention when subjected to repeated charge/discharge cycles and this good capacity retention is considered by the present inventors to be due to the ability of the silicon pillars to absorb the volumetric expansion/contraction associated with lithium insertion/extraction from the host silicon without the
25 pillars being broken up or destroyed. However, the structured silicon electrodes described in the above publication is fabricated by using a high purity, single crystal silicon wafer and hence produces an electrode with a potentially high cost.

The invention is defined in the independent claims. Some optional features of the invention are defined in the dependent claims.

5 The first aspect of this disclosure provides a particle comprising silicon having a particle core and an array of silicon-comprising pillars extending therefrom.

The pillars may be regular or irregular. The pillars may be 0.08 to 0.70 microns in one dimension, preferably 0.1 to 0.5 microns, more preferably 0.2 to 0.4 microns, and most preferably 0.3 microns or above. In a second dimension,
10 the pillars are 4 to 100 microns, preferably 10 to 80 microns, more preferably 30 microns or above. The pillars thus have an aspect ratio of greater than 20:1. The pillars may have a substantially circular cross-section or a substantially non-circular cross-section.

15 The pillared particle may comprise undoped silicon, doped silicon or a mixture, such as a silicon-germanium mixture. In particular, the particle may have a silicon-purity of 90.00% to 99.95% by mass, preferably 90.0% to 99.5%. The silicon can be doped with any material for example, phosphorous, aluminium, silver, boron and/or zinc. The particle may be relatively low purity
20 metallurgical grade silicon.

The particles may be regular or irregular in cross section and can be from 10 μm to 1 mm in diameter, preferably 20 μm to 150 μm , more preferably 25 μm to 75 μm .

25 The second aspect of the disclosure provides a method of fabricating a particle of the first aspect, comprising the steps of etching a particle comprising silicon. In particular, the pillars can be created by chemical reaction etching or galvanic exchange etching.

30 The third aspect of the disclosure provides a composite electrode containing particles as defined in the first aspect of the disclosure as one of its active

materials. In particular, the third aspect provides a composite electrode which uses copper as a current collector. In a feature of the third aspect, the electrode can be an anode.

- 5 The third aspect therefore further provides an electrochemical cell containing an electrode as defined above. In particular, there is provided an electrochemical cell in which the cathode comprises a lithium-containing compound capable of releasing and reabsorbing lithium ions as its active material. In particular, there is provided an electrochemical cell in which the
10 cathode comprises lithium-based metal oxide or phosphate as its active material preferably LiCoO_2 or $\text{LiMn}_x\text{Ni}_x\text{Co}_{1-2x}\text{O}_2$ or LiFePO_4 .

- The disclosure further provides a lithium rechargeable cell anode comprising particles of the first aspect. In particular, there is provided an anode in which
15 the particles are part of a composite.

- The third aspect further provides a cell comprising an anode and a cathode wherein the cathode preferably comprises lithium-based material, more preferably lithium cobalt dioxide.
20

There is further provided a device powered by a cell as defined above.

- The fourth aspect of the disclosure provides a method of creating a composite electrode comprising the steps of preparing a solvent-based slurry containing
25 pillared particles, coating the slurry onto a current collector and evaporating the solvent to create a composite film.

The disclosure further provides a method of fabricating a lithium rechargeable cell comprising the steps of creating an anode as defined above and adding a

cathode an electrolyte. In particular, the method further comprising adding a separator between cathode and the anode. A casing may be provided around the cell.

- 5 There is also provided a method of fabricating silicon-comprising fibres in which the pillars are detached from a particle of the first aspect by one or more of scraping, agitating or chemical etching.

10 The production of an anode electrode structure using the structured particles of as disclosed herein further overcomes the problems of reversibly reacting silicon with lithium. In particular by arranging the particles in a composite structure, that is a mixture of particles, a polymer binder and an conductive additive, or by directing bonding the structured particles to the current collector, the charge/discharge process becomes reversible and repeatable and
15 good capacity retention is achieved. This good reversibility is considered by the present inventors to be due to the ability of the silicon pillars forming part of the structured silicon particle to absorb the volumetric expansion/contraction associated with lithium insertion/extraction from the host silicon without the pillars being broken up or destroyed. Importantly, the silicon electrodes
20 described herein are fabricated by using a low purity, metallurgical grade silicon and hence produces an electrode with a potentially low cost.

Embodiments will now be described, by way of example, with reference to the figures, of which:.

25

Fig. 1 is a schematic diagram showing the components of a battery cell;

Fig. 2 is a electron micrograph of a pillared particle according to embodiments of the present disclosure;

Fig. 3 shows the overall galvanic exchange etching mechanism; and

Fig. 4 shows hypothetical kinetic curves in the form of the partial currents in the galvanic exchange etching process.

In overview the techniques disclosed herein may allow creation of pillared particles of silicon or silicon-comprising material and the use of these particles to create both a composite anode structure with a polymer binder, an conductive additive (if required) and a metal foil current collector and an electrode structure. In particular it is believed that the structure of the particles that make up the composite overcomes the problem of charge/discharge capacity loss. By providing a particle with a plurality of elongate or long thin pillars the problem of charge/discharge capacity loss is reduced.

Typically the pillars will have a length to diameter ratio of approximately 20:1. The insertion and removal of lithium into the pillars, although causing volume expansion and volume contraction, does not cause the pillars to be destroyed and hence the intra-fibre electronic conductivity is preserved.

The pillars can be made on the particles by wet etching/using a chemical galvanic exchange method for example as described in our co-pending application GB 0601318.9 with common assignees and entitled "Method of etching a silicon-based material", incorporated herewith by reference. A related method which may also be used has been disclosed in Peng K-Q, Yan, Y-J Gao, S-P, Zhu J., *Adv. Materials*, **14** (2004), 1164-1167 ("*Peng*"); K. Peng *et al*, *Angew. Chem. Int. Ed.*, **44** 2737-2742; and K. Peng *et al.*, *Adv. Funct. Mater.*, **16** (2006), 387-394; K. Peng, Z. Huang and J. Zhu, *Adv. Mater.*, **16** (2004), 127-132; and T. Qui, L. Wu, X. Yang, G. S. Huang and Z. Y. Zhang, *Appl. Phys. Lett.*, **84** (2004), 3867-3869. The above-mentioned methods are used to produce pillars from a high purity silicon wafer.

In a preferred embodiment, pillars are produced on crystalline particles of relatively low purity silicon such as metallurgical grade silicon. The method comprises the five steps of: grinding and sieving; washing; nucleation; etching; and silver removal, as explained, by way of example only, later. An electron micrograph of pillared particle made in accordance with the techniques disclosed herein is shown in Fig. 2.

Any appropriate grinding process is suitable such as power grinding or ball milling. The skilled person will appreciate that a minimum particle size will exist below which pillars cannot be etched onto the surface and instead the particle will be homogeneously etched away. Particles having a diameter less than 0.5 μm may be too small.

A more uniform pillar array, in terms of density and height, is produced by nucleating before etching. This step produces a uniform distribution of silver nuclei/islands (nuclei combine and form silver islands that are the site for pillar growth).

Silver islands delineate the formation of pillars and galvanic fluoride etching of the {100} planes: see Fig. 3. Referring to Fig. 3 there is shown a silicon surface 301 having a pillar 307. An electron 305 is transferred from a fluoride ion 303 to the silicon surface 301. The reaction of fluorine with silicon 301 and fluoride ions 303 gives rise to fluorosilicate ions 305. This is the anodic etching process. The cathode process is the discharge of silver ions 309 to produce metallic silver 311.

The structure is explained by supposing that silicon—fluoride bonds are formed as an essential step in the etch process. And furthermore that structures that are Si-F (mono-fluoride) are stable and those that are F-Si-F (di-fluoride)

and $\text{Si}[-\text{F}]_3$ (tri-fluoride) are not stable. This is because of steric interference on the Si surface of nearest neighbour groups. The case of the $\{111\}$ plane is that, a mono-fluoride surface, stable except at the edges, inevitably proceeds to a tri-fluoride surface and consequent instability. The $\{110\}$ surface is the only
5 stable major crystal plane of Si that will have exclusively mono-fluoride bonds- hence its stability and the etch rate ratio [etch rate $\langle 100 \rangle$] : [etch rate $\langle 110 \rangle$] of about three orders of magnitude. So the sides of the pillars will be terminated on $\{110\}$ planes.

10 A pillar surface density may be used to define the density of the pillars on the surface of the particle. Herein, this is defined as $F = P / [R + P]$ wherein: F is the pillar surface density; P is the total surface area of the particle occupied by pillars; and R is the total surface area of the particle unoccupied by pillars.

15 The larger the pillar surface density, the larger the lithium capacity per unit area of a silicon particle electrode and the larger the amount of harvestable pillars available to create fibres.

For example, using the above-mentioned silicon powder from Elken of Norway
20 having a pre-etching size of $400 \times 300 \times 200 \mu\text{m}$, pillars are produced all over the surface having a pillar height of approximately 25 to $30 \mu\text{m}$, a diameter of approximately 200 to 500 nm and a pillar surface density, F, of 10-50%, more typically, 30%.

25 For example, particles having a pre-etching size of approximately $63\text{-}80 \times 50 \times 35 \mu\text{m}$ are found to produce pillars with a height of approximately 10 to $15 \mu\text{m}$, with a coverage of approximately 30% and a diameter of approximately 200 to 500 nm

In a preferred embodiment, pillars of for example 100 microns in length and 0.2 microns in diameter are fabricated on and from a silicon-comprising particle. More generally pillars of length in the range of 4 to 100 microns and diameter or transverse dimension in the range of 0.08 to 0.70 microns are
5 fabricated from a particle having an initial size of 10 to 1000 μm .

According to the process, the silicon particles may be predominantly n- or p-type and, according to the chemical approach, and may be etched on any exposed (100), (111) or (110) crystal face. Since the etching proceeds along
10 crystal planes, the resulting pillars are single crystals. Because of this structural feature, the pillars will be substantially straight facilitating length to diameter ratio of greater than 20:1.

The pillared-particles may then be used to form a composite electrode as
15 described later. Alternatively, the pillars may be detached from the particle and used to form a fibre-based electrode. The detached pillars may also be described as fibres.

The disclosure encompasses the detachment of the pillars from the particle.
20 The particle, with pillars attached, can be placed in a beaker or any appropriate container, covered in an inert liquid such as ethanol or water and subjected to ultra-sonic agitation. It is found that within several minutes the liquid is seen to be turbid and it can be seen by electron microscope examination that at this stage the pillars have been removed from the particle.

25 In an embodiment, the pillars are removed from the particle in a two stage process. In the first stage, the particles are washed several times in water and, if necessary, dried in a low vacuum system to remove the water. In the second stage, the particles are agitated in an ultrasonic bath to detach the pillars. These

are suspended in water and then filtered using different various filter paper sizes to collect the silicon fibres.

It will be appreciated that alternative methods for “harvesting” the pillars include scraping the particle surface to detach them or detaching them chemically. One chemical approach appropriate to n-type silicon material comprises etching the particle in an HF solution in the presence of backside illumination.

- Once the pillared particles have been fabricated they can be used as the active material in a composite anode for lithium-ion electrochemical cells. To fabricate a composite anode, the pillared particles are mixed with polyvinylidene difluoride and made into a slurry with a casting solvent such as n-methyl pyrrolidinone. This slurry can then be applied or coated onto a metal plate or metal foil or other conducting substrate for example physically with a blade or in any other appropriate manner to yield a coated film of the required thickness and the casting solvent is then evaporated from this film using an appropriate drying system which may employ elevated temperatures in the range of 50 degrees C to 140 degrees C to leave the composite film free or substantially from casting solvent. The resulting composite film has a porous structure in which the mass of silicon-based pillared particles is typically between 70 percent and 95 percent. The composite film will have a percentage pore volume of 10-30 percent, preferably about 20 percent.
- Fabrication of the lithium-ion battery cell thereafter can be carried out in any appropriate manner for example following the general structure shown in Fig. 1 but with a silicon-comprising active anode material rather than a graphite active anode material. For example the silicon particle-based composite anode layer is covered by the porous spacer 18, the electrolyte added to the final

structure saturating all the available pore volume. The electrolyte addition is done after placing the electrodes in an appropriate casing and may include vacuum filling of the anode to ensure the pore volume is filled with the liquid electrolyte.

5

Some embodiments provide an electrode containing as its active material a plurality of pillared particles of silicon. Capacity retention is improved as the pillared structure of the silicon allows for accommodation of the volume expansion associated with insertion/extraction (charging and discharging) of lithium. Advantageously, the pillared particles may be created by etching lumps of low purity, silicon (termed metallurgical grade silicon) such that a core of silicon remains covered by pillars that are between 0.08 μm and 0.5 μm in diameter and between 4 μm and 150 μm in length.

15 A particular advantage of the approach described herein is that large sheets of silicon-based anode can be fabricated and then rolled or stamped out subsequently as is currently the case in graphite-based anodes for lithium-ion battery cells meaning that the approach described herein can be retrofitted with the existing manufacturing capability.

20

The invention will now be illustrated by reference to one or more of the following non-limiting examples:

Grinding and seiving

25

In the first stage, widely-available metallurgical grade silicon, such as "Silgrain" from Elkem of Norway, was ground and sieved to produce particles in the range 10 to 1000 μm , preferably 30 to 300 μm and more preferably 50 to 100 μm .

Washing

5 The second stage comprised washing the ground and sieved particles in water to remove any fine particles stuck to the big particles. The washed particles were then treated in diluted HNO_3 (1mol·L) or $\text{H}_2\text{SO}_4/\text{H}_2\text{O}_2$ (1:2 in volume) or $\text{H}_2\text{O}_2/\text{NH}_3\text{H}_2\text{O}/\text{H}_2\text{O}_2$ (1:1:1 in volume) in 10 minutes to get rid of the possible organic or metal impurities.

10 Nucleation

In the third stage, a nucleation reaction was carried out in a solution of 17.5 ml HF (40 %) + 20ml AgNO_3 (0.06 mol/l) + 2.5ml EtOH (97.5 %) + 10 ml H_2O for 7~10 minutes at room temperature ($\sim 23^\circ\text{C}$) using 0.1 g of silicon particles
15 with the dimension of about $400 \times 300 \times 200 \mu\text{m}$. For the same weight of silicon, smaller silicon particles required a larger solution volume due to the increased surface area to volume ratio.

The effect of ethanol at room temperature was to slow the chemical processes
20 which gives a more uniform distribution of silver islands. The time (especially at the upper limit) was sufficient to consume a significant amount of the solution silver.

Etching

25

The fourth stage comprised etching. The etching reaction used a solution of 17.5 ml HF (40 %) + 12.5ml $\text{Fe}(\text{NO}_3)_3$ (0.06 mol·l) + 2 ml AgNO_3 (0.06mol·l) + 18 ml H_2O for 1~1.5 hours at room temperature ($\sim 23^\circ\text{C}$) using 0.1 g of silicon particles with the dimension of about $400 \times 300 \times 200 \mu\text{m}$. For the same

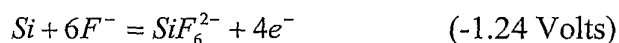
16

weight of silicon, smaller silicon particles required a larger solution volume due to the increased surface area to volume ratio. In addition, as the particle size decreases, a shorter time is needed for smaller silicon particles, for example, 30 min for 100 ~ 120 μm (sieve size) sample and 20 min for 63 ~ 80 μm sample.

In further modifications, stirring increased the etch rate possibly owing to the discharge of hydrogen. Here, the out diffusion of fluorosilicate ion was rate limiting.

The skilled person will understand that oxidizing agents other than Ag^+ may be equally suitable. For example: K_2PtCl_6 ; $\text{Cu}(\text{NO}_3)_2$; $\text{Ni}(\text{NO}_3)_2$; $\text{Mn}(\text{NO}_3)_2$; $\text{Fe}(\text{NO}_3)_3$; $\text{Co}(\text{NO}_3)_2$; $\text{Cr}(\text{NO}_3)_2$; $\text{Mg}(\text{NO}_3)_2$. Compounds involving Cu and Pt, having potentials higher than hydrogen, give metal deposition (Cu and Pt) but the others, except for Ni, do not.

The overall galvanic exchange etching mechanism can be illustrated using Figs 3 and 4. In Fig. 3 the anodic process,



is the local etching of silicon. While the removal of the electrons accompanied by the discharge of silver ions is the cathodic process



For standard conditions the overall cell voltage is 2.04 volts. The other cathodic couples of interest are Cu/Cu^{2+} (+0.35V); $\text{PtCl}_6^{2-}/\text{PtCl}_4^{2-}$ (+0.74V);

$\text{Fe}^{3+}/\text{Fe}^{2+}$ (+0.77V), since they are all positive with respect to hydrogen. Couples that are more negative than H^+/H_2 will be in competition with hydrogen and will be largely ineffective. Fig.4 shows a schematic version of the partial electrode reactions.

5

Silver removal

The final stage of the process involved removing the silver which was left on the etched silicon particles from the third and fourth stages. The silver was removed (and saved) using a solution of 15 % HNO_3 for 5~10 min.

10

It will be appreciated, of course, that any appropriate approach can be adopted in order to arrive at the approaches and apparatus described above. For example the pillar detaching operation can comprise any of a shaking, scraping, chemical or other operation as long as pillars are removed from the particles. The particles can have any appropriate dimension and can for example be pure silicon or doped silicon other silicon-comprising material such as a silicon-germanium mixture or any other appropriate mixture. The particles from which pillars are created may be n- or p- type, ranging from 100 to 0.001 Ohm cm, or it may be a suitable alloy of silicon, for example $\text{Si}_x\text{Ge}_{1-x}$. The particles may be metallurgical grade silicon.

15

20

The particles and/or the detached pillars can be used for any appropriate purpose such as fabrication of electrodes generally including cathodes. The cathode material can be of any appropriate material, typically a lithium-based metal oxide or phosphate material such as LiCoO_2 , $\text{LiMn}_x\text{Ni}_x\text{Co}_{1-2x}\text{O}_2$ or LiFePO_4 . The features of different embodiments can be interchanged or

25

juxtaposed as appropriate and the method steps performed in any appropriate order.

5 Although relatively high purity single crystal wafers of silicon can be etched to produce pillars of the desired parameters, the wafers themselves are very expensive owing to their high purity. Furthermore, it is difficult to arrange a pillared-wafer into an electrode-geometry. Embodiments of the present disclosure are advantageous because metallurgical grade silicon is relatively cheap and pillared particles may themselves be incorporated into a composite
10 electrode without further processing. Also, pillared particles are a good source of silicon fibres and can be used themselves as the “active” ingredient in a battery electrode.

The particles used for etching may be crystalline for example mono- or poly-
15 crystalline with a crystallite size equal to or greater than the required pillar height. The polycrystalline particle may comprise any number of crystals from example two or more.

Advantageously, metallurgical grade silicon is particularly suitable as a battery
20 electrode because of the relatively high density of defects (compared to silicon wafers used in the semiconductor industry). This leads to a low resistance and hence high conductivity.

As the skilled person will understand, both n-type and p-type silicon can be
25 etched and any density of charge carriers is appropriate provided the material does not become significantly degenerate.

CLAIMS

1. A structured particle comprising silicon for an active material of an electrode, the particle having a core having a particle shape and a plurality of silicon-comprising elongate structures extending outwards therefrom.
2. The structured particle as claimed in claim 1 wherein the plurality of silicon-comprising elongate structures are a regular or irregular array of silicon-comprising pillars.
3. The structured particle as claimed in claim 1 wherein the core comprises silicon and has {100}, {111} or {110} crystal surfaces.
4. The structured particle as claimed in any one of claims 1 to 3 wherein the elongate structures comprise silicon-comprising pillars having sides with {110} surfaces.
5. The structured particle as claimed in any one of claims 1 to 3 wherein the elongate structures extend from a plurality of surfaces of the particle core.
6. The structured particle as claimed in any one of claims 1 to 3 wherein the elongate structures extend all over the surface of the particle core.
7. The structured particle as claimed in any one of claims 1 to 3 wherein the fraction of the surface area of the particle core occupied by the elongate structures is 0.10 to 0.50.
8. The structured particle as claimed in any one of claims 1 to 3 in which the elongate structures have a length to diameter ratio of greater than 20:1.

9. The structured particle as claimed in any one of claims 1 to 3 in which the elongate structures have a first dimension in the range 0.08 to 0.70 microns.
10. The structured particle as claimed in any one of claims 1 to 3 in which the elongate structures have a substantially circular cross-section.
11. The structured particle as claimed in any one of claims 1 to 3 in which the elongate structures have a substantially non-circular cross-section.
12. The structured particle as claimed in any one of claims 1 to 3 in which the particle comprises undoped silicon, doped silicon or a silicon germanium mixture.
13. The structured particle as claimed in claim 12 in which the particle comprises doped silicon, wherein the silicon is doped with at least one of phosphorous, aluminum, silver, boron and zinc.
14. The structured particle as claimed in any one of claims 1 to 3 wherein the silicon has a silicon purity of 90.00 to 99.95% by mass.
15. The structured particle as claimed in any one of claims 1 to 3, the particle having a diameter of at least 0.5 μm .
16. The structured particle as claimed in claim 15, the particle having a diameter of 10 μm to 1 mm.
17. An electrode comprising the structured particle as claimed in any one of claims 1 to 3.
18. The electrode as claimed in claim 17 in which the electrode comprises a porous composite comprising a plurality of the structured particles.

19. The electrode as claimed in claim 17 in which the structured particles are directly bonded to a current collector.
20. The electrode as claimed in claim 18 in which the structured particles comprise 70 to 95% by mass of the porous composite.
21. The electrode as claimed in claim 18 wherein the porous composite further comprises at least one of a binder and conductive additive.
22. The electrode as claimed in claims 17 in which the electrode is an electrode for an electrochemical cell and the plurality of structured particles are one of its active materials.
23. The electrode as claimed in claim 22 in which the elongate structures of the structured particles comprise silicon-comprising pillars having sides with {110} surfaces.
24. An electrochemical cell containing an electrode as claimed in claim 22.
25. The electrochemical cell as claimed in claim 24 further comprising a cathode comprising a lithium-containing compound capable of releasing and reabsorbing lithium ions as its active material.
26. A device powered by an electrochemical cell as claimed in claim 24.
27. A method of fabricating an electrode, the method comprising depositing a layer comprising a plurality of structured particles as claimed in any one of claims 1 to 3.

28. A method of creating a composite electrode comprising the steps of preparing a solvent-based slurry containing a plurality of structured particles as claimed in any of claims 1 to 3, coating the slurry onto a current collector and evaporating the solvent to create a porous composite film.
29. A method of fabricating a lithium-ion rechargeable cell comprising the steps of creating an electrode as claimed in claim 27 and adding a cathode and an electrolyte.
30. A method of fabricating a silicon-comprising structured particle as claimed in any one of claims 1 to 3, the method comprising the step of wet etching a silicon-comprising particle.
31. The method as claimed in claim 30, in which the step of wet etching comprises chemical reaction etching, galvanic exchange etching or galvanic fluoride etching.
32. The method as claimed in claim 30, further comprising a nucleation step before etching in which a distribution of silver nuclei are formed on the silicon-comprising particle.
33. The method as claimed in claim 31, in which the step of wet etching comprises galvanic exchange etching comprising an anodic etching process represented by $\text{Si} + 6\text{F}^- = \text{SiF}_6^{2-} + 4\text{e}^-$ and the removal of electrons is accompanied by the discharge of silver ions.
34. The method as claimed in claim 31, comprising the step of depositing a metal from a compound containing Cu or Pt having an electric potential higher than hydrogen onto the silicon-comprising particle.

35. The method as claimed in claim 32, further comprising the step of removing the silver left on the etched structured particles using a solution comprising nitric acid.
36. A method of fabricating silicon-comprising fibres in which elongate structures are detached from the silicon-comprising structured particle as defined by any one of claims 1 to 3 to form the said silicon-comprising fibres.
37. The method as claimed in claim 36 wherein the fibres are detached from the silicon-comprising structured particle by one or more of scraping, agitating or chemical etching.
38. The method as claimed in claim 37 wherein the fibres have sides with {110} surfaces.
39. A method of fabricating an electrode, the method comprising depositing a coating comprising the silicon-comprising fibres fabricated by the method of claim 36.
40. A method of creating a porous composite electrode comprising the steps of preparing a solvent-based slurry comprising the silicon-comprising fibres, fabricated by the method of claim 36, and coating the slurry onto a current collector and evaporating the solvent to create a composite film.
41. An electrode containing a plurality of silicon-comprising fibres fabricated by the method of claim 36, as one of its active materials.
42. An electrochemical cell comprising an electrode as claimed in claim 41.

43. The electrochemical cell as claimed in claim 42 further comprising a cathode comprising a lithium-containing compound capable of releasing and reabsorbing lithium ions as its active material.

44. A device powered by an electrochemical cell as claimed in claim 43.

45. An electrode for an electrochemical cell comprising a plurality of silicon-comprising particles as one of its active materials wherein the silicon-comprising particles comprise at least one of:

(a) a structured particle comprising a core having a particle shape and a plurality of silicon-comprising elongate structures extending therefrom; or

(b) silicon-comprising fibres;

wherein the elongate structures or fibres have sides with surfaces terminating on {110} planes.

46. The structured particle as claimed in claim 1, wherein the core has a faceted shape in which a direction perpendicular to the surface of the core is discontinuously changed.